



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Attn: OIPE

Seigo KODAMA et al.

Group Art Unit: 2125

Application No.: 10/564,815

Docket No.: 126601

Filed: February 14, 2006

For: MANAGING APPARATUS FOR MANAGING ASSISTING WORK TO ASSIST SUBSTRATE-RELATED-WORK PERFORMING SYSTEM, AND MANAGING PROGRAM FOR MANAGING ASSISTING WORK TO ASSIST SUBSTRATE-RELATED-WORK PERFORMING SYSTEM

SECOND REQUEST FOR CORRECTION OF PALM RECORDS

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Attached is a photocopy of the corrected filing receipt on which errors have been corrected in red. These errors are being brought to the attention of the Patent and Trademark Office so that it may correct its records.

Respectfully submitted,

James A. Oliff
Registration No. 27,075

Mario A. Costantino
Registration No. 33,565

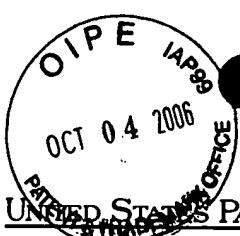
JAO:MAC/jls

Date: October 4, 2006

OLIFF & BERRIDGE, PLC
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APS

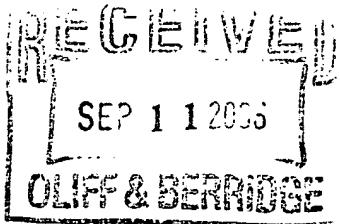


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| APPL NO. | FILING OR 371 (c) DATE | ART UNIT | FIL FEE REC'D | ATTY.DOCKET NO | DRAWINGS | TOT CLMS | IND CLMS |
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| 10/564,815 | 02/14/2006 | 2125 | 1030 | 126601 | 17 | 16 | 2 |

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CONFIRMATION NO. 3390

CORRECTED FILING RECEIPT



OC000000020349379

Date Mailed: 09/08/2006

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please mail to the Commissioner for Patents P.O. Box 1450 Alexandria Va 22313-1450. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

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 Hiroyuki Haneda, Chita-shi, JAPAN;

Assignment For Published Patent Application

Fuji Machine MFG. Co., Ltd., Chiryu-shi, JAPAN
 MFG.

Power of Attorney: The patent practitioners associated with Customer Number 25944.

Domestic Priority data as claimed by applicant

This application is a 371 of PCT/JP04/09956 07/13/2004

Foreign Applications

JAPAN 2003-199391 07/18/2003

If Required, Foreign Filing License Granted: 06/01/2006

The country code and number of your priority application, to be used for filing abroad under the Paris Convention, is **US10/564,815**

Projected Publication Date: Not Applicable

Non-Publication Request: No

Early Publication Request: No

Title

Substrate-related-work

Managing apparatus for managing assisting work to assist substrate-related performing system, and managing program for managing assisting work to assist substrate-related-work performing system

Preliminary Class

700

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